



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

5 Applicant(s): Babich et al.
Docket No.: YOR920030174US1
Serial No.: 10/634,667
Filed: August 5, 2003
10 Group: 1752
Examiner: A.C. Walke

Title: Lithographic Antireflective Hardmask Compositions and Uses Thereof

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Signature: Susan F. Farnsworth Date: November 23, 2005

RESPONSE TO OFFICE ACTION

20 Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

25 Sir:

In response to the outstanding Office Action, dated July 26, 2005, Applicants submit the
30 following remarks.